سلم

	Application No.	Applicant(s)		
Notice of Allowability	09/929,053	TAKAHASHI ET AL.	TAKAHASHI ET AL.	
	Examiner	Art Unit		
	Brian J. Sines	1743		
The MAILING DATE of this communication appeal claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communication is second communication in the communication is second communication.	n this application. If not include unication will be mailed in due	ed course. THIS	
1. A This communication is responsive to the terminal disclaimed	<u>er filed 3/5/2004</u> .			
2. \boxtimes The allowed claim(s) is/are <u>1,2,4 and 5</u> .				
3. 🔀 The drawings filed on 15 August 2001 are accepted by the Examiner.				
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)				
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date	6. ☐ Interview S Paper No '08), 7. ⊠ Examiner's	nformal Patent Application (PT Gummary (PTO-413), ./Mail Date s Amendment/Comment s Statement of Reasons for All		

Application/Control Number: 09/929,053

Art Unit: 1743

DETAILED ACTION

Terminal Disclaimer

The terminal disclaimer filed on 3/5/2004 disclaiming the terminal portion of any patent granted on this application which would extend beyond the expiration date of U.S. Pat. No. 6,337,050 B1 has been reviewed and is accepted. The terminal disclaimer has been recorded.

Allowable Subject Matter

Claims 1, 2, 4 and 5 are allowed.

The following is an examiner's statement of reasons for allowance:

Ohishi et al. (US 6,019,945) teach a sample analysis system comprising a sample container transfer mechanism. Takahashi et al. (US 6,290,907 B1) further teach a sample handling system. The cited prior art neither teach or fairly suggest a sample rack handling system comprising: a rack transportation assembly having a passage capable of transporting a sample rack holding a sample, wherein the rack transportation assembly is supported on a floor surface; and a treatment unit structure having a rack transferring area for sending out and receiving the sample rack to and from the passage, wherein the treatment unit structure is detachably combined with the rack transportation assembly so that the sample rack is transferred from either the rack transferring area or the passage to the other; a projecting member forced on the rack transportation assembly below the passage, wherein the projecting member projects forward from the rack transportation assembly; a first reference surface facing upwardly formed on an upper surface of the projecting member; a plurality of adjusters for adjusting the height of the rack transportation assembly, wherein the adjusters are attached at a position lower that the projecting member on the rack transportation assembly; a second reference surface mounted on

Application/Control Number: 09/929,053

Art Unit: 1743

the treatment unit structure and facing downwardly and located at a position near a back surface of the treatment unit structure, which is lower that the rack transferring area of the treatment unit structure, wherein the second reference surface is maintained in contact with the first reference surface when the treatment unit structure is combined with the rack transportation assembly; and casters for contacting the floor surface when the treatment unit structure is moved on the floor surface, wherein the casters are arranged at a position, which is lower that the second reference surface on the treatment unit structure, wherein the casters each have a height adjuster for adjusting a height of the treatment unit structure so that the second reference surface is brought into and maintained in contact with the first reference surface.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Brian J. Sines whose telephone number is (571) 272-1263. The examiner can normally be reached on Monday - Friday (11:30 AM - 8 PM EST).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Jill A. Warden can be reached on (571) 272-1267. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

* Application/Control Number: 09/929,053

Art Unit: 1743

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jili Warden
Supervisory Patent Examiner
Technology Center 1700